



Substitute for form 1449/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Application Number	10/817,620
				Filing Date	April 1, 2004
				First Named Inventor	Carl Woods
				Art Unit	SLW 1746-1709
				Examiner Name	SLW Unassigned Joy Watson
Sheet	1	of	5	Attorney Docket Number	LAM2P474

U.S. Patent Documents

Examiner Initials	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
JW/	A	2003/0091754	05/15/03	Chihani et al.	
	B	2003/0092264	05/15/03	Shinji et al.	
	C	2004/0060573	04/01/04	Woods	
	D	2004/0069319	04/15/04	Boyd et al.	
	E	2004/0069329	04/15/04	De Larios et al.	
	F	2004/0136494	07/15/04	Lof et al.	
	G	2004/0178060	09/16/04	Ravkin et al.	
	H	2004/0182422	09/23/04	Boyd et al.	
	I	2005/0132515	12/18/03/05	Boyd et al.	
	J	2005/0139318	06/30/05	Woods et al.	
	K	2005/0145265	07/07/05	Ravkin et al.	
	L	2005/0145267	04/01/04/05	Korolik et al.	
	M	2005/0145268	04/01/04/05	Woods	

Foreign Patent Documents

Examiner Initial	Cite No. ¹	Foreign Patent Document No.	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
JW/	N	EP 1 489 461 A1	12/22/04	ASML Netherland B.V.		<input type="checkbox"/>
JW/	O	EP 1 489 462 A2	12/22/04	ASML Holding N.V.		<input type="checkbox"/>

Non Patent Literature Documents

Examiner Initial	Cite No.	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
JW/	P	OWA et al. "Immersion lithography; its potential performance and issues", Proceedings of the SPIE, SPIE, Bellingham, VA, US, Vol. 5040, No. 1, February 28, 2003, pages 724-733, XP002294500
SLW	Q	LIM et al., "Atomic Layer deposition of transition metals", Department of Chemistry and Chemical Biology, Harvard University, Nature Publishing Group, Volume 2, November 2003, Pages 749-754

Examiner Signature	/Joy Watson/ (08/09/2007)	Date Considered	(08/09/2007)
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Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language